

Attorney's Docket No.: 12732-034001 /US4891

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Koichiro Tanaka

Art Unit : 2822

Serial No.: 09/842,797

Examiner: Maria F. Guerrero

Filed

: April 27, 2001

Title

: METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP AF

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MAY 21, 2004

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 18 of this paper.

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